

# LEDIA2022 – Invited Speakers

Åsa Haglund

(Chalmers University of Technology)

Tatsushi Hamaguchi

(Sony Corporation)

Bao-Ping Zhang

(Xiamen University)

Ryan C White

(UCSB)

Ken Goto

(Tokyo University of Agriculture and Technology)

Karolina Grabińska

(Institute of High Pressure Physics, PAS, Ammono sp. z o.o)

Tomoaki Sumi

(Panasonic Corporation)

Tomohiro Nishitani

(Photo Electron Soul)

Kazutoshi Kato

(Kyushu University)

Kenjiro Uesugi

(Mie University)